

AF 2823



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Examining Group 2823

PATENT
Customer No. 22,852
Attorney Docket No. 04329.2622

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Gaku MINAMIHABA, et al.) Group Art Unit: 2823
)
Serial No.: 09/932,943) Examiner: Lee, Hsien Ming
)
Filed: August 21, 2001)
)
For: SLURRY FOR CHEMICAL)
MECHANICAL POLISHING AND)
METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE)

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Sir:

SUPPLEMENTAL AMENDMENT AFTER FINAL

Supplemental to the Amendment After Final filed on July 24, 2003, Applicants propose further amending the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.

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